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APPENDIX A: MARKED-UP CLAIMS

1. (Twice amended) A metal-to-metal antifuse formed over a lower Cu metal layer planarized with the top surface of a lower insulating layer comprising:

a metal layer disposed under said lower Cu metal layer; a lower barrier layer disposed over [the] <u>said</u> lower Cu metal layer; an antifuse material layer disposed over said lower barrier layer; an upper barrier layer disposed over said antifuse material layer; an upper insulating layer disposed over said upper barrier layer;

and

layer;

an upper Cu metal layer planerized with a top surface of the upper insulating layer and having a contact extending therethrough to make electrical contact with said upper barrier.

- 4. (Amended) The metal-to-metal antifuse of claim 1 wherein said lower barrier material layer comprises a layer of TaN[.], said lower barrier layer encladded in said first cap layer.
- 10. (Twice amended) A method for fabricating a metal-to-metal antifuse comprising:

forming a metal layer under a lower Cu metal layer planarized with the top surface of a lower insulating layer;

forming a lower barrier layer over [a] <u>said</u> lower Cu metal layer [planarized with the top surface of a lower insulating layer];

forming an antifuse material layer over said lower barrier layer; forming an upper barrier layer disposed over said antifuse material

forming an upper insulating layer disposed over said upper barrier layer and said antifuse layer;

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forming a via in said upper insulating layer to expose a top surface of said upper barrier layer;

forming an upper Cu metal layer over said upper insulating layer and in said via to make electrical contact with said upper barrier layer; and

planarizing a top surface of said upper Cu metal layer and a top surface of said upper insulating layer.